

Electronic Patent Application Fee Transmittal

Application Number:	10765140			
Filing Date:	28-Jan-2004			
Title of Invention:	Sputtering apparatus, a mixed film produced by the sputtering apparatus and a multilayer film including the mixed film			
First Named Inventor/Applicant Name:	Masao Miyamura			
Filer:	Marvin Jay Spivak/Melissa Snyder			
Attorney Docket Number:	248212US2			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				810